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Yaasin A. MAYI, Patrice PEYRE, Michel BELLET, Charlotte METTON, Clara MORICONI, Remy FABBRO, Morgan DAL - Erratum: "Transient dynamics and stability of keyhole at threshold in laser powder bed fusion regime investigated by finite element modeling" [J. Laser Appl. 33, 012024 (2021)] - Journal of Laser Applications - Vol. 33, n°2, p.029902 - 2021

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Erratum: “Transient dynamics and stability of keyhole at threshold in laser powder bed fusion regime investigated by finite element modeling” [J. Laser Appl. 33, 012024 (2021)]

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The authors would like to inform the readers that erroneous Figs. 4 and 5 were unfortunately uploaded during the proof revision process of the original paper.¹ The correct figures are below.

The authors wish to apologize for any inconvenience caused by this error.

REFERENCES

¹Y. A. Mayi, M. Dal, P. Peyre, M. Bellet, C. Metton, C. Moriconi, and R. Fabbro, “Transient dynamics and stability of keyhole at threshold in laser powder bed fusion regime investigated by finite element modeling,” *J. Laser Appl.* 33, 012024 (2021).

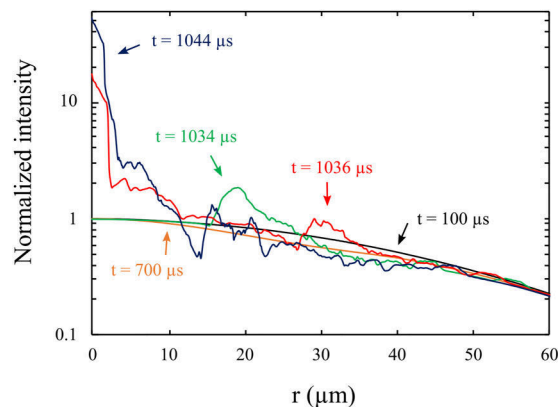


FIG. 4. Distribution of normalized absorbed laser intensity (log scale) at different instants.

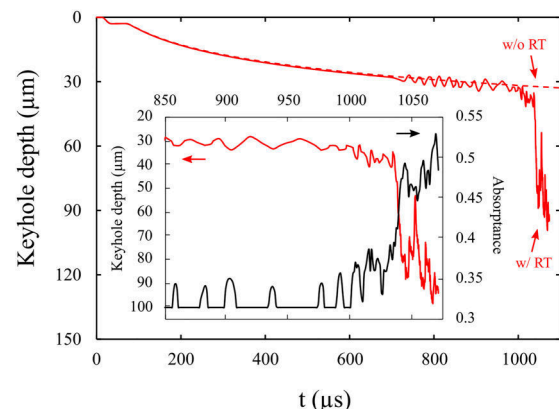


FIG. 5. Keyhole depth (with and without RT) and absorbance over time in the static configuration.